



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Gas-Assisted Rapid Thermal Processing
Serial No.: 10/005,827 Filing Date: November 8, 2001
Examiner: Trinh, Michael Manh Group Art Unit: 2822
Docket No.: M-11914 US

Irvine, California
November 24, 2004

Mail Stop Issue Fee
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.312

Dear Sir:

Pursuant to 37 C.F.R. § 1.312, Applicants respectfully request the Examiner to enter the following amendments in the above-identified application.

IN THE DRAWINGS

Please replace sheets 1 and 2 of the previously submitted formal drawings.
Replacement sheets 1 and 2 are enclosed with this document.

REMARKS

Pursuant to 37 C.F.R. § 1.312, Applicants request entry of the above amendments, which are being filed together with the payment of the issue fee. Applicants have amended the drawings and are submitting replacement sheets as per the Examiner's request.

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